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Docket No. 0756-1398

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Takeshi FUKUNAGA et al.)
Serial No. 08/519,420) Art Unit: 1112
Filed: August 25, 1995) Examiner M. Padgett
For: METHOD OF MANUFACTURING)
A SEMICONDUCTOR DEVICE) May 23, 1996

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on May 23, 1996.

Deborah T. Tomme
Deborah T. Tomme

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment and Petition for One Month Extension of Time in the above-identified application.

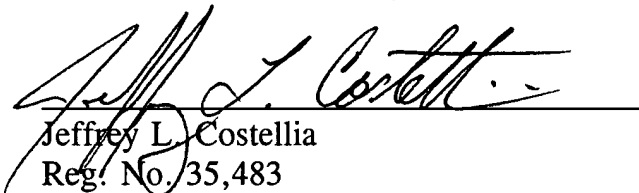
- [] Small entity status of this application under 37 C.F.R. 1.9 and 1.27 has been established by a verified statement previously submitted.
- [] A verified statement to establish small entity status under 37 C.F.R. 1.9 and 1.27 is enclosed.
- [] No additional fee is required.

The fee has been calculated as shown below:

	Claims Remaining After Amendment		Highest Number Previously Paid For	Present Extra	Rate Sm/Lg Entity	Fee
Total	20	Minus	22	-0-	X 11/22	-0-
Indep.	8	Minus	7	1	X 39/78	78.00
First presentation of multiple dependent claims						-0-
TOTAL						78.00

- [X] A check in the amount of \$78.00 to cover the filing fee is enclosed.
- [X] In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380 (0756-1398).
- [X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380 (0756-1398). A duplicate copy of this sheet is attached.

Respectfully submitted,


Jeffrey L. Costellia
Reg. No. 35,483

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2010 Corporate Ridge, Suite 600
McLean, Virginia 22102
(703) 790-9110



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For: METHOD OF MANUFACTURING)
A SEMICONDUCTOR DEVICE) May 23, 1996

AMENDMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed January 23, 1996, please amend the above-identified application as follows.

IN THE TITLE:

Please replace the Title with the following:

--A METHOD OF MANUFACTURING A SEMICONDUCTOR
DEVICE INCLUDING LASER IRRADIATION FOLLOWED BY
THERMAL ANNEALING--

RECEIVED
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GROUP 110

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